



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Reiki WATANABE

Serial No.: 10/743,314

Filed: December 23, 2003

For: PROCESSING EQUIPMENT AND PROCESSING METHOD

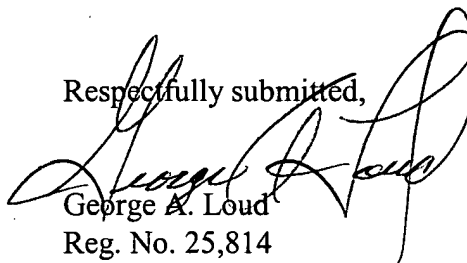
INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(1)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record the six (6) documents listed on the attached. Copies of the two Japanese language documents, published English language abstracts thereof, and a copy of the literature article by Tuomo Suntola are also submitted herewith.

Respectfully submitted,

  
George A. Loud  
Reg. No. 25,814

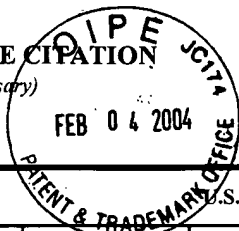
Dated: February 4, 2004

LORUSSO, LOUD & KELLY  
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Alexandria, VA 22305

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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

OKA-C387

Application Number

10/743,314

Applicant(s)

Reiki WATANABE

Filing Date

12/23/03

Group Art Unit

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,879,459	3/9/99	GADGIT et al	118	715	
		6,174,377	1/16/01	DOERING et al	118	729	
		6,387,185	5/14/02	DOERING et al	118	729	

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2002-4054	1/9/02	JP				
		2001-348666	12/18/01	JP				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Handbook of Thin Film Process Technology, B1.5:1-B1.5.17, 1995 IOP Publishing Ltd.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.